

**BEYER WEAVER & THOMAS, LLP**

INTELLECTUAL PROPERTY LAW

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**FACSIMILE COVER SHEET**

June 29, 2004

**Receiver: Office of Initial Patent Examination**

**TEL #:** (703) 308-1202

**FAX #:** (703) 746-9195

**Sender: Joseph E. Bond**

**Our Ref. No.: NOVLP091**

**Re: 10/820,525**

**Pages Including Cover Sheet(s): 4**

**MESSAGE:**

Please see attached request to correct the filing receipt.

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re application of: Wu et al.

Attorney Docket No.: NOVLP091

Application No.: 10/820,525

Examiner: Not Yet Assigned

Filed: April 7, 2004

Group: 2812

Title: METHODS FOR PRODUCING LOW-K  
CDO FILMS WITH LOW RESIDUAL STRESS

Confirmation No.: 8337

**CERTIFICATE OF FACSIMILE TRANSMISSION**

I hereby certify that this correspondence is being transmitted by facsimile to fax number (703) 746-9195 to the U.S. Patent and Trademark Office on June 29, 2004.

Signed: 

Laura M. Dean

**REQUEST FOR CORRECTED FILING RECEIPT**Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Enclosed is a copy of the Filing Receipt for the above-identified patent application. Please reprint the Filing Receipt as follows and mail the corrected copy to the undersigned.

Change the Title "METHOD FOR PRODUCING LOW-K CDO FILMS WITH LOW RESIDUAL STRESS" to -- METHODS FOR PRODUCING LOW-K CDO FILMS WITH LOW RESIDUAL STRESS --.

Please correct the first inventor's name. "Oinggou WU" should be --Qinggou WU--.

Since this is a Patent Office typographical error, no fee should be due. However, the Commissioner is authorized to charge any fees that may be due to Deposit Account 500388 (Order No. NOVLP091).

Respectfully submitted,

BEYER WEAVER &amp; THOMAS, LLP

Joseph E. Bond  
Registration No. 52,633P.O. Box 778  
Berkeley, CA 94704-0778



**METHODS**

~~Method~~ for producing low-k CDO films with low residual stress

**Preliminary Class**

438

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Title 37, Code of Federal Regulations, 5.11 & 5.15**

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